



Docket No. 740756-2100

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE APR -5 2002  
TC 2800 MAIL ROOM

In re Patent Application of: )  
Hongyong ZHANG et al. ) Group Art Unit: 2812  
Application Serial No. 09/633,869 ) Examiner: Victor Simkovic  
Filed: August 7, 2000 )  
For: METHOD FOR LASER- ) Date: March 29, 2002  
PROCESSING SEMICONDUCTOR  
DEVICE

CERTIFICATE OF MAILING

**REQUEST FOR RECONSIDERATION**

Commissioner for Patents  
Washington, D.C. 20231

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231 on March 29, 2002  
Gwyn J. Cantrell  
Gwyn J. Cantrell

Sir:

Responsive to the Office Action of November 30, 2001, the statutory period for response having been extended one (1) month to **March 30, 2002**, the following remarks are submitted in connection with the above-identified application.

**REMARKS**

The Office Action of **November 30, 2001**, has been received and its contents carefully noted. Filed concurrently herewith is a *Request for a One (1) Month Extension of Time* which extends the shortened statutory period for response to **March 30, 2002**. Accordingly, Applicant respectfully submits that this response is timely filed. Claims 1-72 are pending in the present application and, for the reasons set forth below, are believed to be in condition for allowance.

**A. 35 U.S.C. §112, 1st Paragraph Rejection**

Initially, the Examiner rejects claims 1-72 under 35 U.S.C. §112, 1st paragraph as allegedly containing subject matter which was not described in the specification in such a